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ATTORNEY DOCKET NO. FIRST NAMED INVENTOR CONFIRMATION NO. FILING DATE APPLICATION NO. 02/26/2002 Hyeon-Su An 8028-16 7098 10/084,284 (SPX200110019US) **EXAMINER** 22150 7590 01/31/2005 F. CHAU & ASSOCIATES, LLC LUU, THANH X 130 WOODBURY ROAD ART UNIT PAPER NUMBER WOODBURY, NY 11797

DATE MAILED: 01/31/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)
Office Action Summary		10/084,284	AN, HYEON-SU
		Examiner	Art Unit
		Thanh X. Luu	2878
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply			
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).  Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).			
Status			
1)🖂	Responsive to communication(s) filed on 06 December 2004.		
· <u> </u>		nis action is non-final.	
3)□	Since this application is in condition for allow closed in accordance with the practice under	•	
Disposition of Claims			
5)⊠ 6)⊠ 7)□			
Application Papers			
<ul> <li>9) The specification is objected to by the Examiner.</li> <li>10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.  Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).</li> <li>11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.</li> </ul>			
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) All b) Some * c) None of:  1. Certified copies of the priority documents have been received.  2. Certified copies of the priority documents have been received in Application No.  3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.			
Attachment(s)			
2)  Notic 3) Inforr	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 or No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da  5) Notice of Informal P  6) Other:	

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#### **DETAILED ACTION**

## Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on December 6, 2004 has been entered.

Claims 1, 3, 4, 6, 7 and 11-13 are currently pending.

## Claim Rejections - 35 USC § 112

2. The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

3. Claims 12 and 13 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention.

It appears that Applicant has failed to disclose an embodiment in which light <u>from</u> an array of damage detecting sensors are received.

4. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

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5. Claims 4, 12 and 13 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

Regarding claim 4, "the second area" lacks proper antecedent basis.

Regarding claims 12 and 13, it is unclear how light is received <u>from</u> a detecting sensor. Furthermore, it is unclear what is doing the receiving and how a light and the emitted rays are related.

## Claim Rejections - 35 USC § 102

6. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 7. Claim 11 is rejected under 35 U.S.C. 102(b) as being anticipated by Cheng et al. (U.S. Patent 4,819,167).

Regarding claim 11, Cheng et al. disclose (see Fig. 3) a method of positioning a wafer, comprising: inserting a peripheral region of a wafer (15) to a sensor body; emitting rays (67-69) from an array of luminous emitters (64-66) on a first surface of the sensor body; receiving emitted rays by an array of photo detecting sensors (61-63) on a second surface of the sensor body opposite the first surface; and determining a position

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(with 25) of the wafer based on the emitted rays received by the array of photo detecting sensors.

8. Claim 11 is rejected under 35 U.S.C. 102(b) as being anticipated by Baker et al. (U.S. Patent 4,880,348).

Regarding claim 11, Baker et al. disclose (see Fig. 2) a method of positioning a wafer, comprising: inserting a peripheral region of a wafer (62) to a sensor body; emitting rays from an array of luminous emitters (LEDs) on a first surface of the sensor body; receiving emitted rays by an array of photo detecting sensors (CCD) on a second surface of the sensor body opposite the first surface; and determining a position of the wafer based on the emitted rays received by the array of photo detecting sensors.

9. Claim 11 is rejected under 35 U.S.C. 102(e) as being anticipated by Bonora et al. (U.S. Patent 6,298,280).

Regarding claim 11, Bonora et al. disclose (see Fig. 2) a method of positioning a wafer, comprising: inserting a peripheral region of a wafer to a sensor body; emitting rays from an array of luminous emitters (48a) on a first surface of the sensor body; receiving emitted rays by an array of photo detecting sensors (48b) on a second surface of the sensor body opposite the first surface; and determining a position of the wafer based on the emitted rays received by the array of photo detecting sensors.

## Allowable Subject Matter

- 10. Claims 1, 3, 6 and 7 are allowed over the prior art of record.
- Claim 4 would be allowable if rewritten to overcome the rejection(s) under 35
   U.S.C. 112, 2nd paragraph, set forth in this Office action and to include all of the

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limitations of the base claim and any intervening claims.

## Response to Arguments

12. Applicant's arguments with respect to claims 11-13 have been considered but are most in view of the new ground(s) of rejection.

#### Conclusion

13. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thanh X. Luu whose telephone number is 571-272-2441. The examiner can normally be reached on M-F 6:30AM-4:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Dave Porta can be reached on 571-272-2444. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Thanh X Luu Primary Examiner Art Unit 2878